

Detection and Analysis System of Low Frequency Electronic Noise in High Power Semiconductor Laser Diodes

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Abstract

Detection and analysis of noise are meaningful to nondestructive examination and reliability representation of high power semiconductor laser diodes. In this thesis a test and analysis bench was designed, which can both test real electronic noise of the laser diodes and analysis with software. Under a series small current injection, we get the low frequency 1/f electronic noise. Realized the separation of 1/f noise and zero mean white noise, using wavelet analysis using the test and analysis platform. Obtain the value of γ from the relationship between the frequency exponent factor γ and Hurst index, then, realize the feature extraction of 1/f noise.

Keywords

High power semiconductor laser diodes ; Wavelet analysis; 1/f noise; Fractal signal analysis.

1. Introduction

Electrical features as a characterization tool for semiconductor devices have been a long time. For example the electrical derivative data method with Jiawei Shi as its respective ^[1], and the low frequency electrical noise method with Yisong Dai as its respective^[2], all produce a new field of the research field for semiconductor laser diodes. But Fengli Gao discovered disadvantage of electrical derivative data method, it has some universal problems, and the low frequency noise method has sensitivity, universality, avoiding destroying features, will become as an important approach to appraise the reliability of semiconductor laser diodes. In this paper, we design a set of platform including both hardware and software to detect and analysis the low frequency electrical noise parameters of high power semiconductor laser diodes to evaluate the reliability of the semiconductor devices. 1/f noise has fractal and self-similarity features, using FFT(Fast Fourier Transform) to solve the cross-correlation spectrum, analysis the 1/f noise under different small inject current. Solve the Hurst index and obtain the frequency index of 1/f noise γ .

2. Measurement of noise signal

In order to get more accuracy 1/f noise data of high power semiconductor laser diodes, we design the hardware measurement platform by cross-correlation spectrum method, using Matlab and Labview hybrid programming establish the software analysis platform, shown in Fig1.

Across-correlation measurement method will effectively restrain the white noise in the measurement results. The two amplifiers are not correlative, assume the signals of tunnel 1, 2 are:

$$X_1(t) = x_1(t) + w_1(t) \quad (1)$$

$$X_2(t) = x_2(t) + w_2(t) \quad (2)$$

$x_1(t)$, $x_2(t)$ are the low frequency voltage noise of the amplifiers, $w_1(t)$ and $w_2(t)$ are the zero mean value addition noise of the two amplifiers. They are not correlative, then:

$$R_{x_1, x_2}(\tau) = E[[x_1(t) + w_1(t)][x_2(t + \tau) + w_2(t + \tau)]] \tag{3}$$

$$= E[x_1(t)x_2(t + \tau)] + E[x_1(t)w_2(t + \tau)] + E[x_2(t + \tau)w_1(t)] + E[w_1(t)w_2(t + \tau)]$$

Where, $E[w_1(t)] = 0$, and $E[w_2(t)] = 0$, then, from (3), we can get:

$R_{x_1, x_2}(\tau) = E[x_1(t)x_2(t + \tau)] = R_{x_1, x_2}(\tau)$, it will eliminate the zero mean value addition noise, and the cross-correlative spectrum simplified as (4) :

$$S_{x_1, x_2}(\omega) = \int_{-\infty}^{+\infty} R_{x_1, x_2}(\tau) e^{-j\omega\tau} d\tau = \int_{-\infty}^{+\infty} R_{x_1, x_2}(\tau) e^{-j\omega\tau} d\tau \tag{4}$$

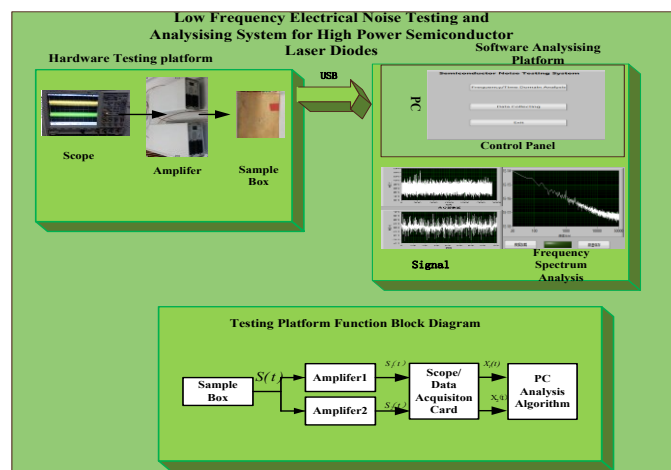


Fig1. The structure of low frequency electronic noise measurement and analysis in high power semiconductor laser diodes

This will promote accuracy of the measured value. In Fig1. we use the Model5184 amplifier from Perkin Elmer, the range of frequency-response from 0.5Hz to 1MHz. The magnification is 10^3 .

In this paper, we use 4,9v batteries to reduce the noise. The functions of the measurement and analysis platform, including signal collecting, signal denoising, frequency analysis. The software can be expanded for further research.

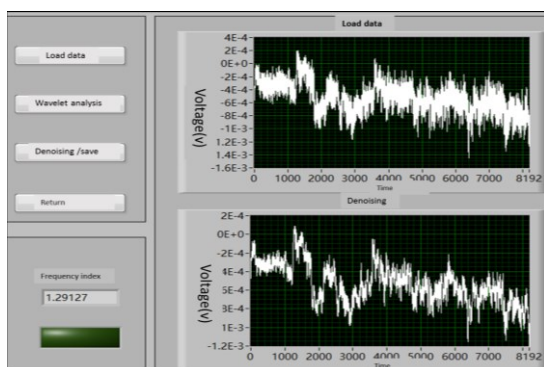


Fig2. Wavelet denoising of #18 device

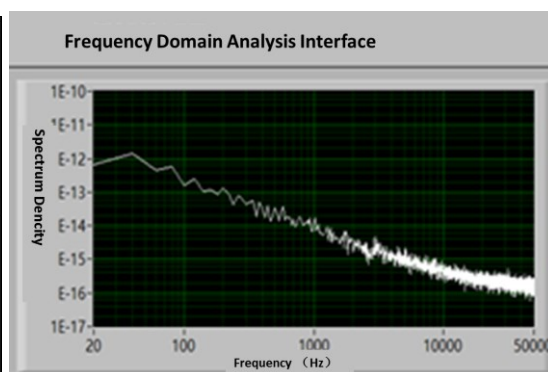


Fig3 The Power spectrum analysis of #18 device

3. Analysis of the noise signal

To number #018 high power semiconductor laser diode, under the small inject current of 0.15ma-3.9ma, obtain a series noise, the main component part is 1/f noise. Using the software analysis platform, by wavelet denoising we get the signal in fig2. below. And its power spectrum is shown in fig3.

1/f is a kind of fractal signal, is an unstable stochastic signal, it is fractal in space, and self-similar in time domain. The power spectrum of 1/f fractal is the reciprocal of its frequency.

$$S_x(\omega) \sim \frac{\sigma_x^2}{|\omega|^\gamma} \tag{5}$$

Where, $S_x(\omega)$, σ_x^2 , γ are the power spectrum density, the variance, spectrum index of noise signal, respectivel. When the 1/f fractal signal get through the filter expressed as formula(5),

$$H(j\omega) = \begin{cases} 1, & \omega_0 < |\omega| \leq \omega_1 \\ 0, & \text{else} \end{cases} \tag{6}$$

where, $0 < \omega_0 < \omega_1 < \infty$

its power spectrum density is:

$$S(\omega) = \begin{cases} \frac{\sigma_x^2}{|\omega|^\gamma}, & \omega_0 < |\omega| \leq \omega_1 \\ 0, & \text{else} \end{cases} \tag{7}$$

where, $\sigma_x^2 > 0$, the relationship between fractal index γ and the similar parameter H is: $\gamma = 2H + 1$. We can get the frequency index γ from Hurst index. The power spectrum density curves under different small inject current are shown in fig4.

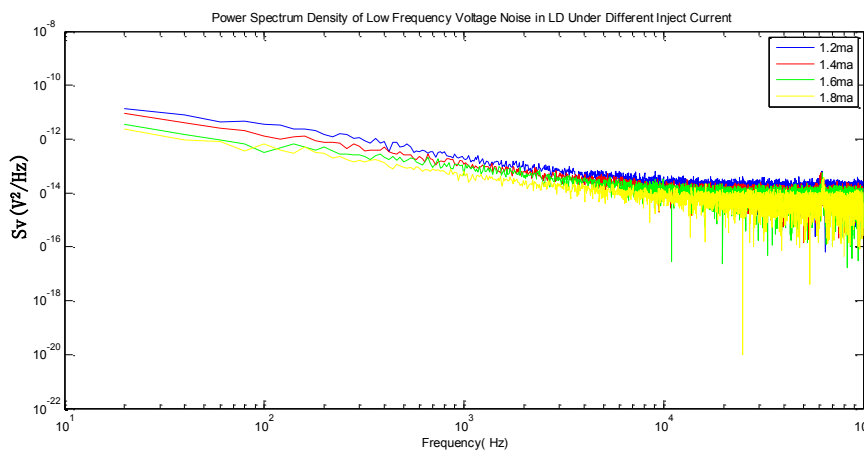


Fig4. Power Spectrum Density of Low Frequency Voltage Noise in LD Under Different Inject Current

Using the software platform, we can obtain the Hurst index of every curve, then calculate frequency index γ , as shown in table 1.

Table 1. Frequency index under different current

Inject current	Frequency index
1.2ma	0.142556
1.4ma	0.181504
1.6ma	0.694771
1.8ma	0.291443

4. Conclutions

In this thesis, we design a platform to measurement and analysis low frequency voltgace noise in high power semiconductor laser diodes. Test the voltage I/f noise under small inject current variance continuously. In range of 1.2ma-1.8ma ,the low frequency voltage noise value in devices will reduce when the small inject current increase. Apply the platform we also calculate the frequency index using wavelet analysis method.

References

- [1] Jiawei Shi.etc.The Character of Voltage Saturation and Reliability of High Power Semiconductor Laser Diodes.Chiese Journal of Lasers.vol.35.No 9.2008.9
- [2] YISONG DAI,JIESUNG SHI and XINFA ZHANG.A STUDY OF OPTICAL NOISE MEASUREMENT AS A RELIABILITY ESTIMATION FOR LASER DIODES. Microelectron. Reliab. Vol.35. NO.4,PP.731-734,1995
- [3]X.Y. Chena,C. Salmb, F.N. Hoogea, P.H. Woerleeb. $1/f$ noise in polycrystalline SiGe analyzed in terms of mobility fluctuations. Solid-State Electronics 43 (1999) 1715-1724.
- [4] X. Y. Chen, A. Pedersen, O. G. Hellesø, et al. Electrical noise of laser diodes measured over a wide range of bias currents. Microelectronics Reliability, 2000, 40: 1925-1928
- [5] K.Sarpatwari a, L. Passmore a, S.A. Suliman a,b, O.O. Awadelkarim. Analysis of curren–voltage–temperature characteristicsin SiC Schottky diodes using threshold-accepting simulated-annealing techniques.Science Direct Solid-State Electronics 51 (2007) 644–649
- [6] Mario El-Tahchi, Antonio Khoury, Marc De Labardonnie",Pierre Mialhe, FreHdeHric Pelanchon. Degradation of the diode ideality factor of silicon n-p junctions. Solar Energy Materials & Solar Cells 62 (2000) 393-98
- [7] Y. Deshayes, L. Bechou, L. Mendizabal, Y. Danto. E arly failure signatures of 1310 nm laser modules using electrical, optical and spectral measurements. Measurement 34 (2003) 157–178